

# Progress & challenges associated with large scale laser surface treatment for SEY reduction

M. Himmerlich on behalf of CERNs TE-VSC team



ECLOUD'22 - 28.09.2022

#### **Outline**

- 1. Laser treatment for SEY reduction: from proof of principle to possible treatments of LHC beam screens
- 2. Fundamental studies and their conclusions
- 3. How far have we come?

LESS (laser engineered surface structuring) = LASE





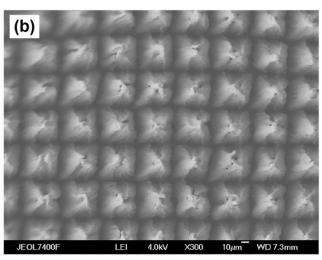
## History of LESS for low SEY & E-cloud mitigation

APPLIED PHYSICS LETTERS 105, 231605 (2014)

# Low secondary electron yield engineered surface for electron cloud mitigation

Reza Valizadeh, <sup>1</sup> Oleg B. Malyshev, <sup>1,a)</sup> Sihui Wang, <sup>1</sup> Svetlana A. Zolotovskaya, <sup>2</sup> W. Allan Gillespie, <sup>2</sup> and Amin Abdolvand <sup>2</sup> <sup>1</sup> ASTeC, STFC Daresbury, Laboratory, Daresbury, Warrington, Cheshire WA4 4AD, United Kingdom

<sup>2</sup>School of Engineering, Physics and Mathematics, University of Dundee, Dundee DD1 4HN, United Kingdom



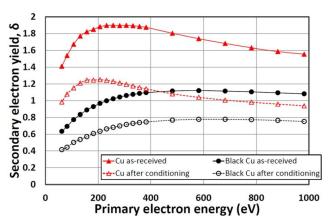
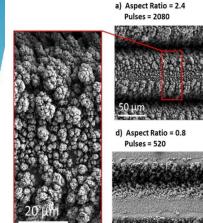


FIG. 3. SEY for Cu as a function of incident electron energy: Cu—untreated surface, black Cu—laser treated surface, and conditioning—electron bombardment with a dose of  $1.0 \times 10^{-2} \text{ C} \cdot \text{mm}^{-2}$  for Cu and  $3.5 \times 10^{-3} \text{ C} \cdot \text{mm}^{-2}$  for black Cu.

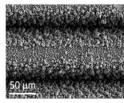




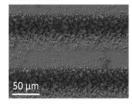
#### **LESS** studies



b) Aspect Ratio = 1.3 Pulses = 1040

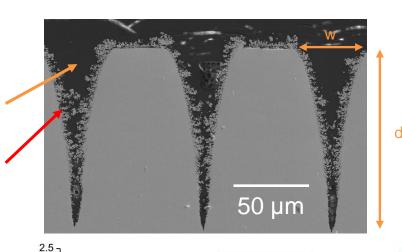


e) Aspect Ratio = 0.7 Pulses = 416



ablated volume

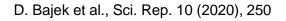
redeposited dendritic nanoparticle layer

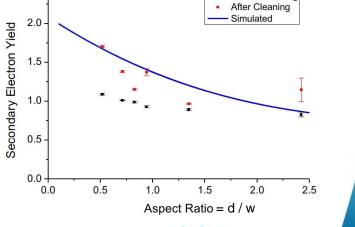


Ablation depth, trench distance and SEY can be tuned via laser parameter adjustment









Before Cleaning

## **E-cloud monitoring in the SPS**

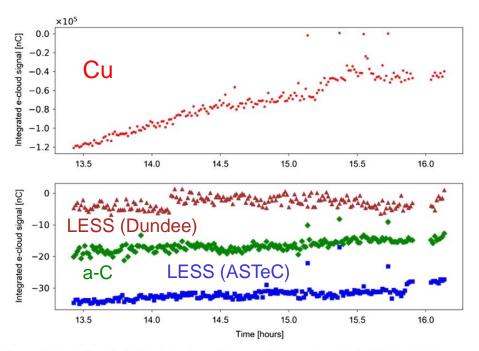
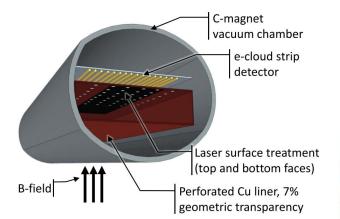


FIG. 12. Integrated signals from the ECMs during the total duration of the experiment in the SPS. (top) Reference copper liner; (bottom) liners with e-cloud mitigation: blue squares—treated by ASTeC, brown triangles—treated at the University of Dundee and green lozenges—a-C coating. Note the difference in vertical scales.

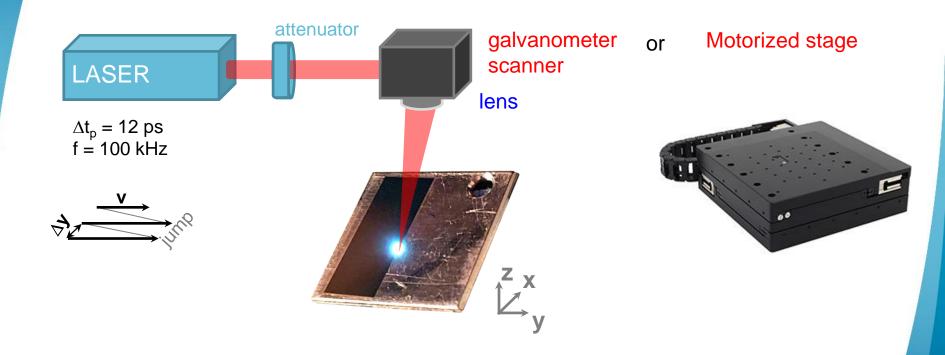


a-C coating and LESS of Cu enable electron cloud suppression





# Laser surface processing & scale-up

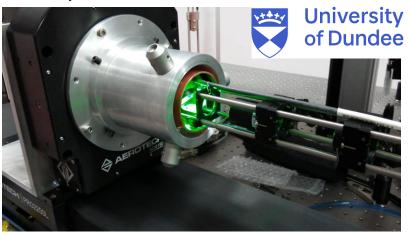






#### **Treatment of inner surfaces?**

Courtesy of A. Abdolvand & S. Wackerow



Difficulty: guide the laser light towards the surface to be treated and define the spot size and focus

or



up to 2 meter insertion depth

Limitations:

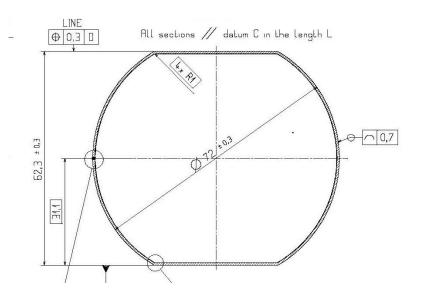
- → tube has to be rotated
- → minimal inner diameter
- → maximal insertion depth
- → circular cross-sections only



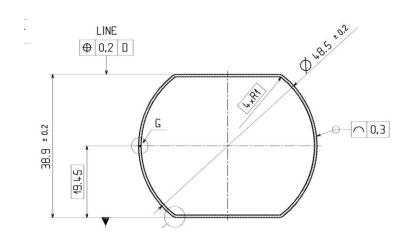


# How about 10 m long beam screens (BS)?

#### LHC Triplet magnets BS



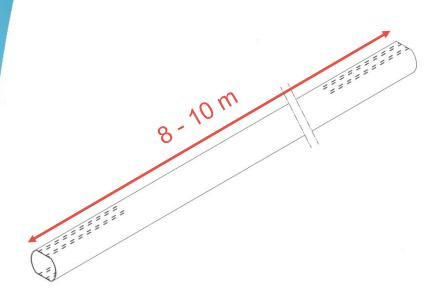
#### LHC Q5 standalone magnet BS

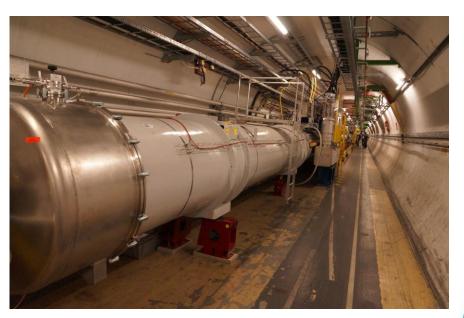






## How about 10 m long beam screens (BS)?

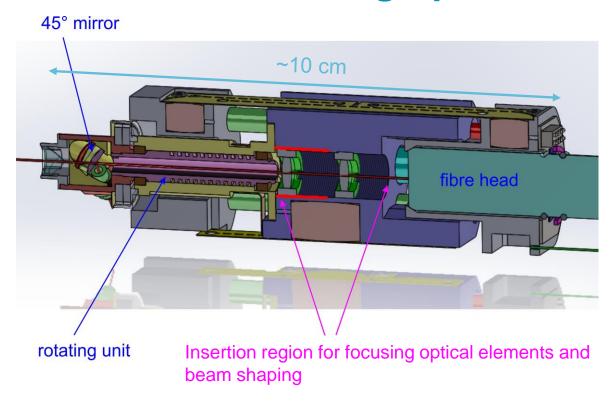








## Inchworm robot for high-precission movement





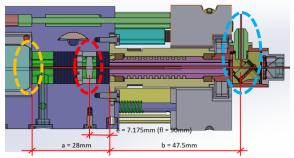




#### **HiLUMI-UK** collaboration









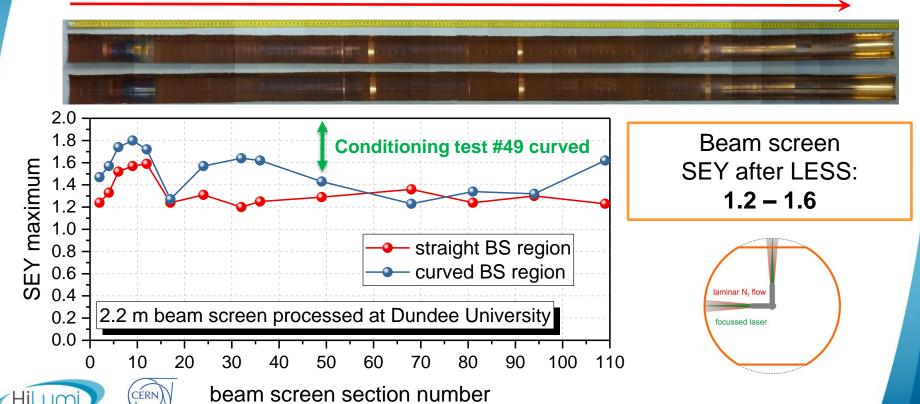




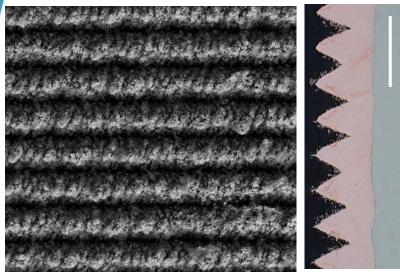


## SEY analysis of laser-treated beam screen

timeline of treatment including, focus & parameter optimization



#### LESS beam screen characteristics

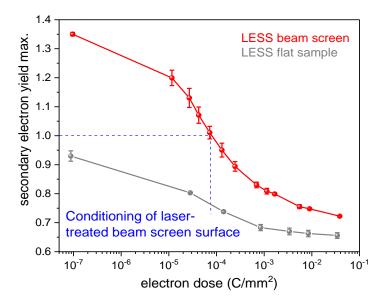


100 µm

- homogeneous stripe pattern achieved
- inhomogeneities in curved regions
- ablation depth too high (> 25 μm)



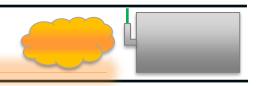


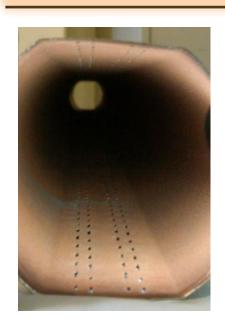


- SEY higher compared to flat samples
- surface conditions to SEY<1 for electron doses <10<sup>-4</sup> C/mm<sup>2</sup> @ 250 eV
- promising to find optimized conditions in terms of treatment speed, ablation depth and final SEY after conditioning

## Particle generation and dust in beam screen

Vacuum Extraction Unit











## Lessons learnt and aspects to be improved

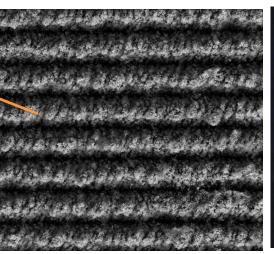
- Laser-fibre coupling was unstable and caused several damages on the fibre that required maintenance at the factory (long down-time)
- SEY of the surface was inhomogeneous due to partial treatment out of focus
- Amount of lying particles on the bottom inacceptable
- Ablation depth too large (target < 25 μm)</li>
- Effective treatment speed quite low





#### **LESS: Main concerns**

ablated dust & adhering particles as risk to fall and interact with the proton beam





ablation of material & influence on surface impedance (particles & grooves)





## **Cryosorbers in standalone magnets**



- Magnets operated at 4.2 K are equipped with cryosorbers
- In-situ a-C coating in presence of installed cryosorbers is almost impossible due to warm-up and gas release during plasma deposition
- Target: treatment of Q5 magnet from IP1 and IP5 on surface

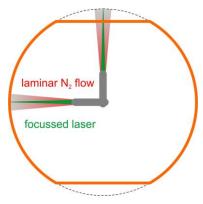
#### **Outline**

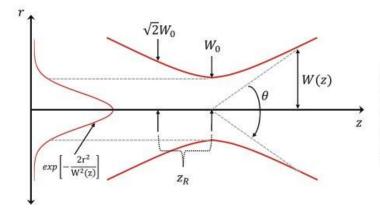
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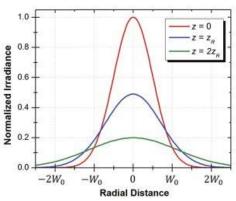


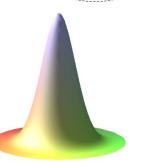


#### **Effects of Gaussian beams of out-of-focus**









$$w_0 = \frac{\lambda \cdot f_l \cdot M^2}{\pi \cdot w_{in}}$$

$$z_R = \frac{\lambda \cdot f_l^2 \cdot M^2}{\pi \cdot w_{in}^2}$$

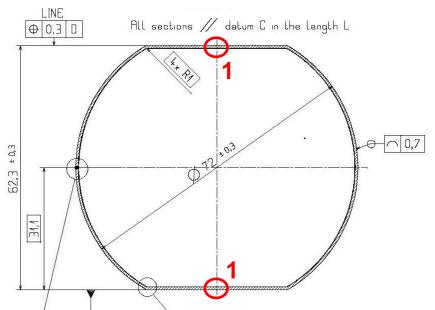


$$z_R = \frac{\pi \cdot w_0^2}{\lambda \cdot M^2}$$

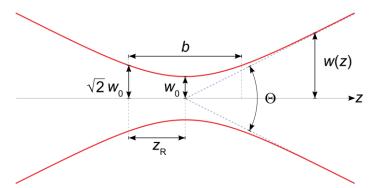




## BS shape and laser focussing



- Radius difference between curved
  BS part and point 1 is 4.85 mm
- If focus is set in-between, the max. focus offset would be  $\pm 2.43 \text{ mm}$
- ightharpoonup Current lens settings: f = 90 mm 2w<sub>0</sub> = 52 µm, z<sub>R</sub> = 3.2 mm
- > at z<sub>R</sub>, intensity is only 50% of that in focus

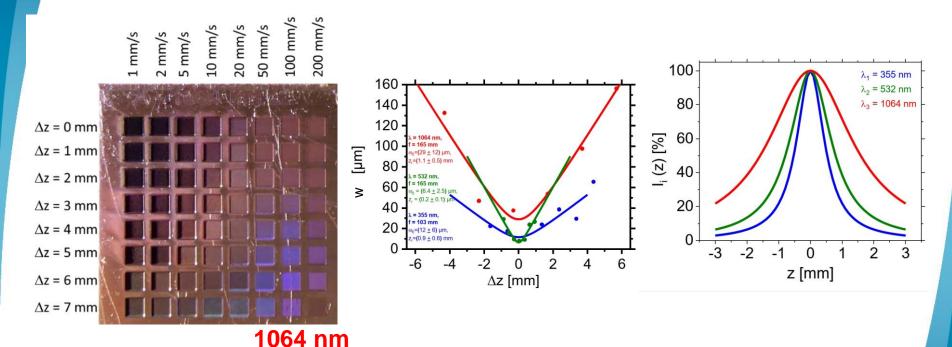


Focus size dependence of a Gaussian Beam





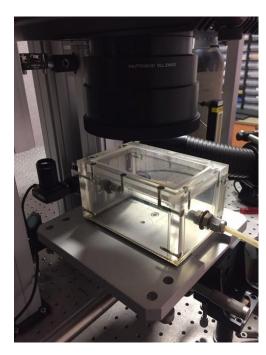
## BS shape and laser focussing



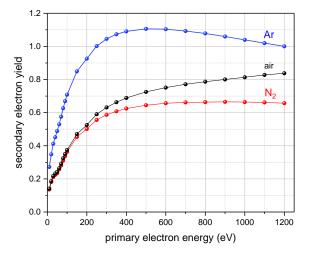


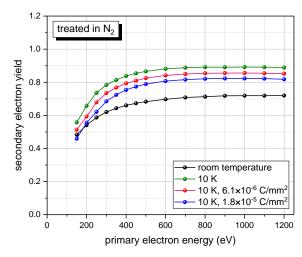


## LESS: Influence of ambient gas during processing



Inert gas box for laser treatment



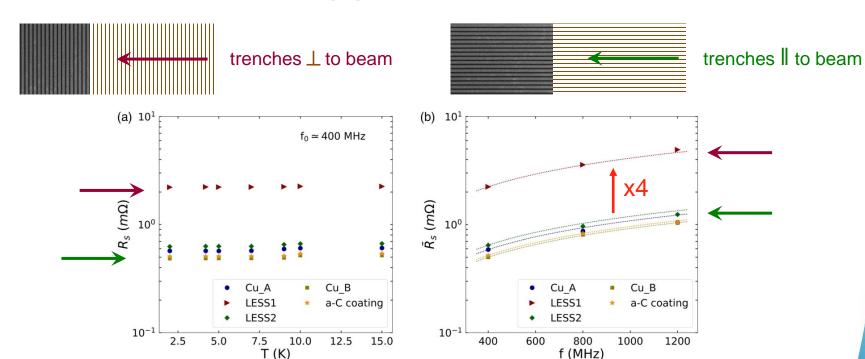


- treatment in air results in strong surface oxidation (provokes charge-up at cryogenic temperatures)
- > treatment in nitrogen prevents surface oxidation
- → all setups are designed to blow N₂ into the reaction zone



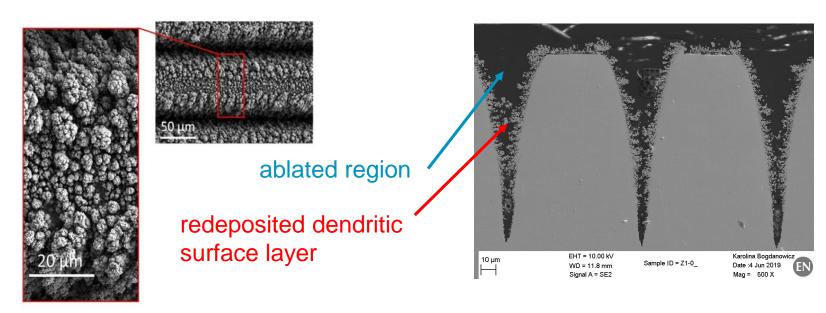


#### Influence of LESS on surface resistance



- Trench depth needs to limited
- Trench alignment ideally longitudinal to beam

## LESS – what about the particles?



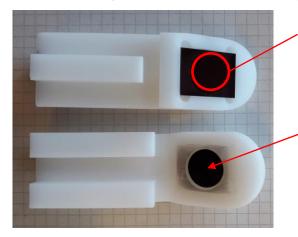
- Particles are ablated and partially redeposited (they adhere but can be wiped off)
- Ablation depth, trench distance and SEY can be tuned via laser parameter adjustment
- Evacuation system extracts flying particles from the beam screen during processing





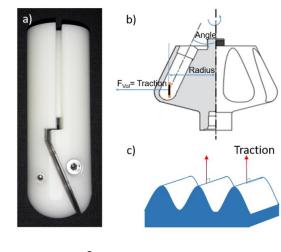
## LESS – particle release during a quench

#### Centrifugation tests (very pessimistic scenario)



Surface submitted to centrifuge force to be analyzed

Particles collected on carbon sticker



30 N/mm<sup>2</sup>

~ 50000 rpm

- Force active during centrifugation equivalent to situation of a magnet quench
- Material analysis after process

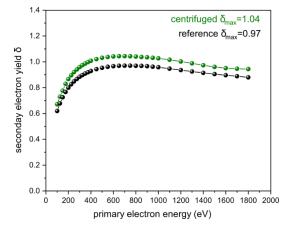


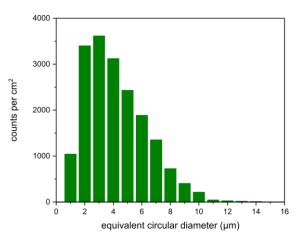


## Particle release during a magnet quench

#### Centrifugation tests (very pessimistic scenario)







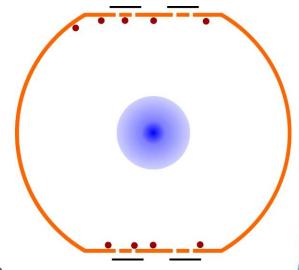
- Number of released particles is relevant but implemented test conditions do not reflect typical operation conditions
- All particles have diameters lower than critical (<15 μm) for beam dump</li>
- Smaller falling objects can still have influence on beam quality and intensity
- Negligible effect on SEY





## LESS – to do: test effect of lying particles

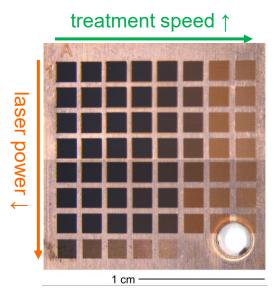
- Risk of falling particles with significant effect during operation (attraction if negatively charged)
- Metallic or oxidized particles that lie on the BS bottom due to inefficient cleaning or due to release after a quench are of concern
- Removal of ablated particle by constant evacuation and gas flow during processing and post-treatment cleaning tools
- Measure on a test bench if such particles could get polarized or charge-up, and even get attracted by the beam



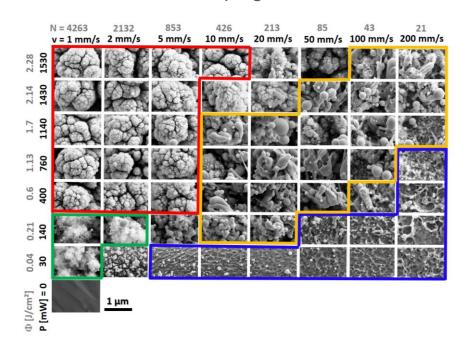




Laser parameter screening in collaboration with IOM Leipzig

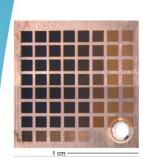


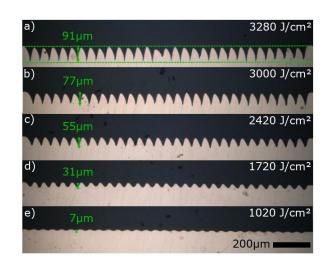
Parameters: power, wavelength, scan velocity, line distance, pulse frequency/duration, focus spot size, ambient gas



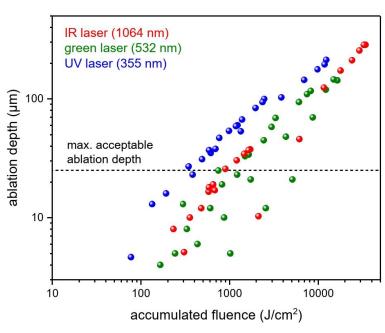
→ Surface topography depends on laser fluence

Laser parameter screening in collaboration with IOM Leipzig





E. Bez et al., Influence of wavelength and accumulated fluence on secondary electron yield of picosecond laser-induced surface roughening of copper

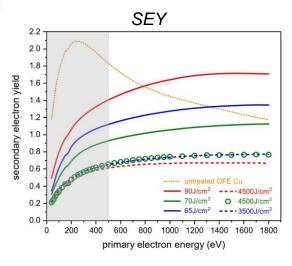


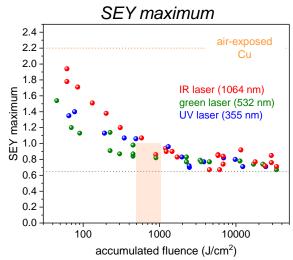
→ Ablation depth depends on laser fluence

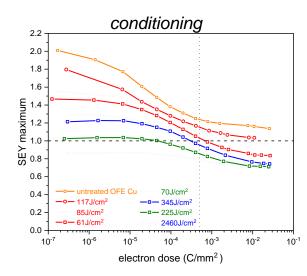




Laser parameter screening in collaboration with IOM Leipzig







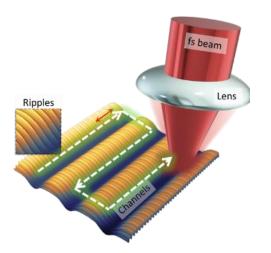
→ The parameter space for SEY engineering is large and depends on laser wavelength E. Bez et al., Influence of wavelength and accumulated fluence on secondary electron yield of picosecond laser-induced surface roughening of copper

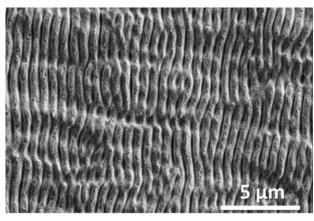


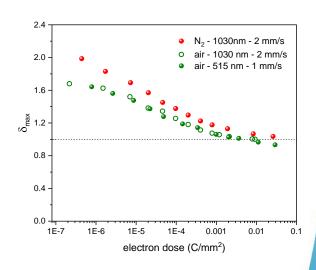


#### **Laser-Induced Periodic Surface Structures**

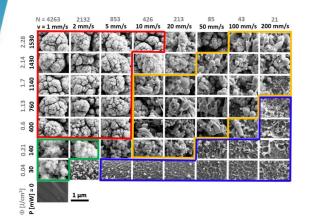
LIPSS studies in collaboration with INFN Naples

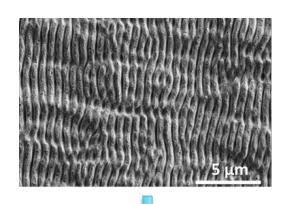


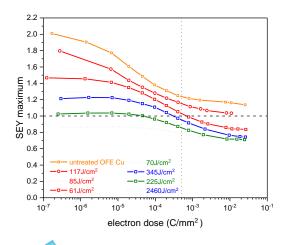




- LIPSS ideally free of particles
- Surface roughening leads to slight reduction of SEY ( $\delta_{max}$  1.6)









- ✓ limit ablation depth
- ✓ reduce particle density
- compromise on SEY compensated by conditioning

To do: transfer to CERN setup





## Agreement in CERNs E-cloud working group

Optimization of laser treatment for lower particle generation and low trench depth

- → Initial SEY maximum of the surface will be > 1
- → Conditioning at reasonable doses will enable SEY < 1

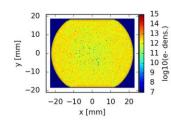
#### Target for LESS performance:

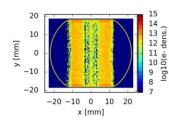
- ✓ initial SEY maximum of the processed surfaces ≤ 1.5
- ✓ Conditioning allows to reduce SEY max. to < 1 for a dose ≤ 5×10<sup>-4</sup> C/mm<sup>2</sup>

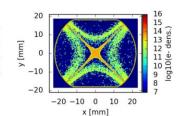


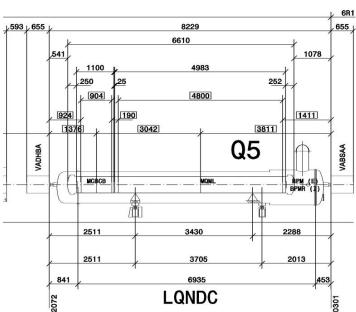


## **Q5** magnet LESS treatment strategy

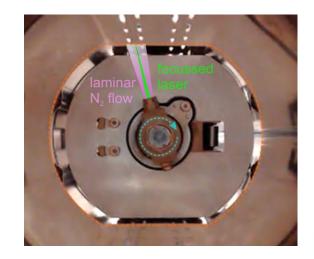








P. Dijkstal, G. ladarola, L. Mether, and G. Rumolo, "Simulation studies on the electron cloud build-up in the elements of the LHC Arcs at 6.5 TeV," Tech. Rep. CERN-ACC-NOTE-2017-0057, CERN, 2017.

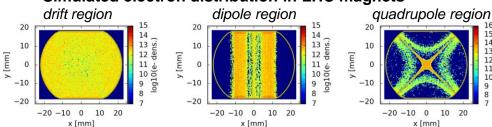






## **Q5** magnet LESS treatment strategy

#### Simulated electron distribution in LHC magnets

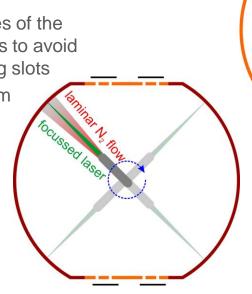


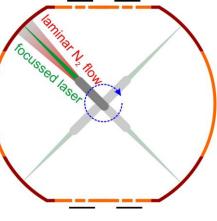
P. Dijkstal, G. ladarola, L. Mether, and G. Rumolo, "Simulation studies on the electron cloud build-up in the elements of the LHC Arcs at 6.5 TeV," Tech. Rep. CERN-ACC-NOTE-2017-0057, CERN, 2017.

Selected LESS treatment in the curved zones of the beam screens for drift region or the 4 corners to avoid burning the cryosorbers through the pumping slots

→ Reduced risk of particles falling into the beam

- Cleaning tools can pass
- → Impedance "problems" disappear
- → Focusing "problems" disappear
- Faster treatment possible





## **LESS** – particle mitigation strategies

- Reduce number of released particles during processing and number of adhered particles via process optimisation (SEY < 1.5, also beneficial for lower surface impedance and limited ablation depth)
- Reduce risk of particles falling into the beam by spatially selective treatment
- Extract majority of ablated particles via a strong air flow thorough the pipe
  (50 l/min) via a extraction and filtering unit
- Post-processing passage with "cleaning unit/carrier" without touching the treated regions





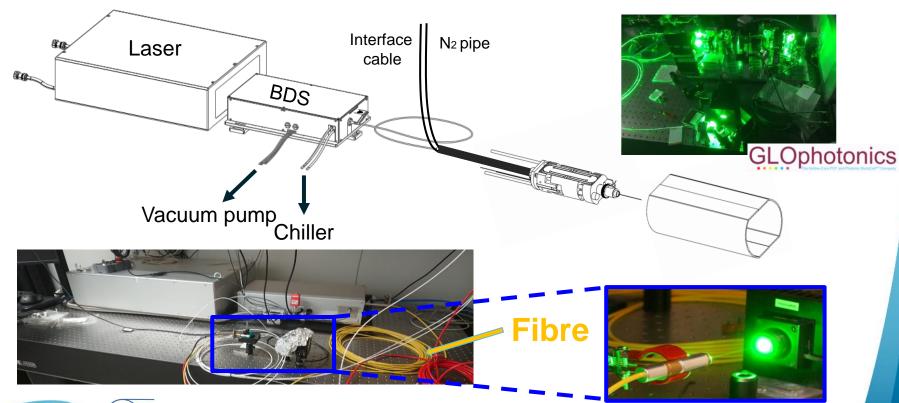
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### LESS @ CERN – 532 nm R&D system



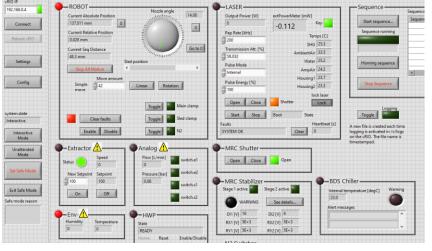


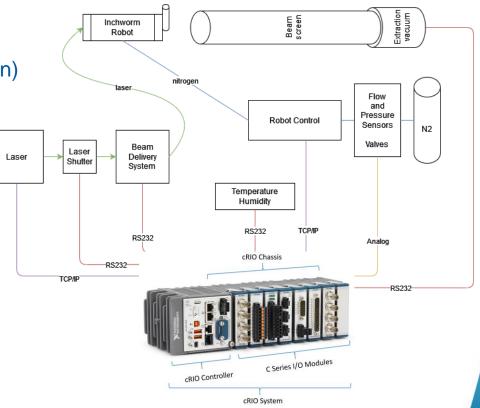


## Integrated control system

System control development In collaboration with BE-CEM-MTA (J. Tagg, P. J. Koziol, O. O. Andreassen)

NI compact RIO + LabVIEW



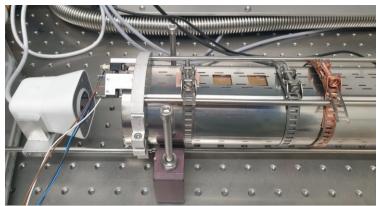


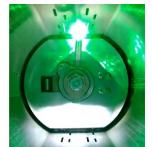
J. Tagg, JACoW ICALEPCS2021 (2022) 492-496, DOI: 10.18429/JACoW-ICALEPCS2021-TUPV039

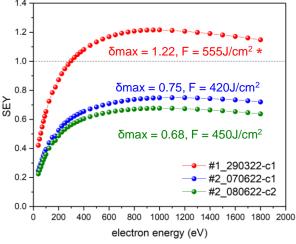
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## LESS @ CERN – where are we and where do we want to go

- Test bench on 74 mm BS finally operational and first optimisation on small scale ongoing
- Vacuum extraction and treatment scale-up components are available







- Low SEY can be obtained with 532 nm on small scale
- First parameter optimisation, speed-up and stability tests started



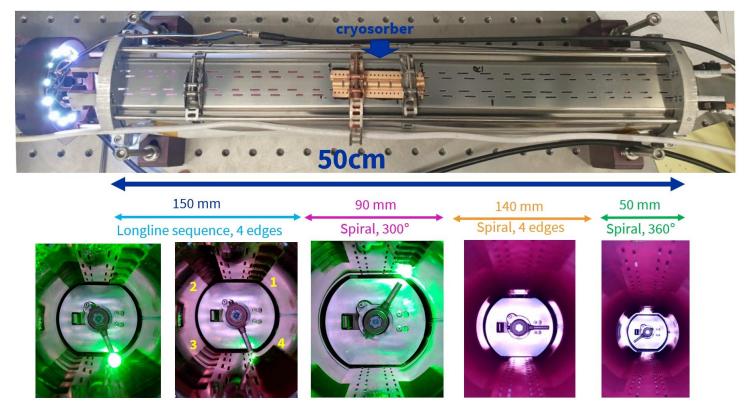








#### Test of patterns and adapted treatment strategy







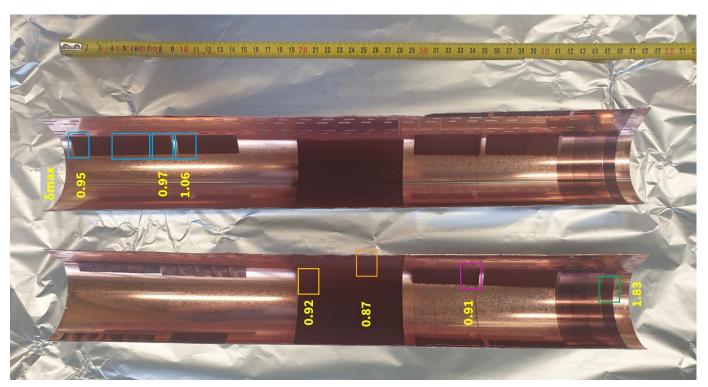
## Test of patterns and adapted treatment strategy







## Test of patterns and adapted treatment strategy







## **Summary**

- Precise robot movement and laser scanning in BS in operation (limited to BS shape)
- Delivery of laser power to BS surface stable
- Treatments are reproducible and can be selectively varied in treatment position and SEY
- Suppression of oxidation and strategies to control surface impedance developed
- Final processing considers: low SEY vs. number of particles





## **Upcoming Tasks & Challenges**

- Transition to 50L beam screen geometry
- Scale up treatment to 8 m long beam screen
- Cable and fibre handling and synchronization with robot during processing > 2m
- Development of a post-treatment cleaning unit
- Demonstration of E-cloud mitigation and stable conditions in Vacuum Pilot Sector of the LHC





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